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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al. Art Unit : 1765
Serial No. : 09/966,689 Examiner : Kin-Chan Chen
Filed : September 27, 2001
Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF
FORMING A WIRING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 3, 2003

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.